



PATENT  
005018USA  
7828.7056

In re Application of )  
TEPMAN, et al. ) Examiner: W. David Coleman  
Serial No.: 10/074,854 )  
Filed: February 11, 2002 ) Art Unit: 2823

For: VARIABLE FLOW DEPOSITION APPARATUS AND METHOD IN SEMICONDUCTOR SUBSTRATE  
PROCESSING

COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.  
The fee (large entity basis) has been calculated as shown below:

Total claims	6	less claims previously paid for	51	=	x fee (\$18) = \$0
Independent claims	1	less claims previously paid for	6	=	x fee (\$86) = \$0
Total claims fee:					

☒ A check in the amount of \$ 110 to cover the extension fee is enclosed.  
☐ A check in the amount of \$      to cover the filing fee is enclosed.  
☐ A check in the amount of \$      to cover the petition fee is enclosed.

☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-0585. A duplicate of this sheet is enclosed.

☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.  
☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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Dated: 1/22/04

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail on the date indicated above and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

William K. Konrad

1/22/04  
(Date)



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TEPMAN, et al.	)	
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For: VARIABLE FLOW DEPOSITION APPARATUS AND METHOD IN SEMICONDUCTOR  
SUBSTRATE PROCESSING

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sirs:

Relating to the Office Action dated September 22, 2003 in the above-referenced application, response to which is due January 22, 2004 with a one-month extension of time (petition for which is attached hereto), please enter and consider the following amendments: